

Application/Control No.	Applicant(s)/Patent under Reexamination
10/621,879	EISSA, MONA M.
Examiner	Art Unit
Kin-Chan Chen	1765

	SEARCHED					
а	858	Subclass	Oate		Examiner	
1:	34	4	4/11/2005		k-cc	
2	52	79.1				
4	38	745	•			
		754				
		756				
4	38	757	4/1	65	Ł	·u
_ <u>~</u>	oda	ed	4/1	65 7/= 6 /. 6	Ł	ic c
0	Desc	ted ted	9/1	/. 6	4	rec
	<i>1</i>					

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
134	79.1	17/06	100		
438	745		Ì		
	754				
438	75-7	9/1/06	KU4		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
	DATE	EXMR			
East keywords search USpat, USpat put. Epo, JPO, IBM-TOB.	4/1/5	k-c4			
updated	4/17/6	KCL			
repolated up dated	9/17/06	Kec			
		;			